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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Wagner  
Serial No. : 10/826,823  
Filed : April 15, 2004  
Title : OPTICAL ARRANGEMENT AND PROJECTION EXPOSURE SYSTEM FOR  
MICROLITHOGRAPHY WITH PASSIVE THERMAL COMPENSATION

Art Unit : 2851  
Examiner : Fuller, Rodney Evan

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION DATED MARCH 13, 2007

Please amend the application as indicated in the following pages:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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Date of Deposit

April 10, 2007

\_\_\_\_\_  
Signature

Terra Hatch

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Typed or Printed Name of Person Signing Certificate

Terra Hatch